

Docket No.: K5675.0034/P034
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jong W. Kim et al.

Application No.: Not Yet Assigned

Confirmation No.: NYA

Filed: Concurrently Herewith

Art Unit: N/A

For: MASS PRODUCTION METHOD FOR
THREE-DIMENSIONAL MICRO
STRUCTURE HAVING HIGH ASPECT
RATIO

Examiner: Not Yet Assigned

CLAIM FOR PRIORITY

MS Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby claims priority under 35 U.S.C. 119 based on the following
prior foreign application filed in the following foreign country on the date indicated:

<u>Country</u>	<u>Application No.</u>	<u>Date</u>
Korea, Republic of	10-2003-0078423	November 6, 2003

Application No.: Not Yet Assigned

Docket No.: K5675.0034/P034

In support of this claim, a certified copy of the said original foreign application will be filed shortly.

Dated: February 23, 2004

Respectfully submitted,

By 

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